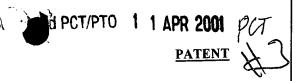
Atty. Docket No. 33764R003



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Andre Luiz Arias, et al.

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For

: RADIATION SENSITIVE COATING COMPOSITION USEFUL FOR LITHOGRAPHIC

PRINTING PLATES AND THE LIKE

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) together with a copy of each reference cited therein. It is respectfully requested that the cited documents be considered by the Examiner in the aboveidentified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,

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